

Sughrue

SUGHRUE MION, PLLC

November 16, 2001

BOX PATENT APPLICATION

Commissioner for Patents
Washington, D.C. 20231

Re: Application of Tsutomu SHOKI and Morio HOSOYA
SUBSTRATE WITH MULTILAYER FILM, REFLECTION TYPE MASK BLANK
FOR EXPOSURE, REFLECTION TYPE MASK FOR EXPOSURE AND
PRODUCTION METHOD THEREOF AS WELL AS PRODUCTION METHOD OF
SEMICONDUCTOR DEVICE
Assignee: **HOYA CORPORATION**
Our Ref. Q67319

Dear Sir:

Attached hereto is the application identified above including twenty-eight (28) sheets of the specification, including the claims and abstract, and four (4) sheets of drawings. The executed Declaration and Power of Attorney and Assignment will be submitted at a later date. Also enclosed is the Information Disclosure Statement.

The Government filing fee is calculated as follows:

Total claims	24	-	20	=	4	x	\$18.00	=	\$72.00
Independent claims	6	-	3	=	3	x	\$84.00	=	\$252.00
Base Fee									\$740.00
Multiple Dependent Claim Fee									\$280.00
TOTAL FEE									\$1344.00

A check for the statutory filing fee of \$1344.00 is attached. You are also directed and authorized to charge or credit any difference or overpayment to Deposit Account No. 19-4880. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 and any petitions for extension of time under 37 C.F.R. § 1.136 which may be required during the entire pendency of the application to Deposit Account No. 19-4880. A duplicate copy of this transmittal letter is attached.

Priority is claimed from November 22, 2000 based on Japanese Application No. 356292/2000. The priority document will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By:

Alan J. Kasper

Registration No. 25,426

AJK/amt